

F. rm PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0756-2401

Serial No. N/A

INFORMATION DISCLOSURE STATEMENT

Applicants: Akira MASE

Filing Date: November 29, 2001

Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
<i>al</i>	3,079,282 ✓	02/01/1963	Haller et al.			
	3,621,564 ✓	11/01/1971	Tanaka et al.			
	3,822,467 ...	07/09/1974	Symersky			
	3,928,658 ✓	12/01/1975	van Boxtel et al.			
	3,983,284 ✓	09/01/1976	Croset			
	4,105,816 ✓	08/01/1978	Hori			
	4,113,578 ✓	09/01/1978	Del Monte			
	4,113,981 ✓	09/01/1978	Fujita et al.			
	4,145,120	03/20/1979	Kubota			
	4,201,801 ✓	05/01/1980	Hori			
	4,327,124 ✓	04/27/1982	DesMarais, Jr.			
	4,427,715 ✓	01/01/1984	Harris			
	4,510,179 ✓	04/01/1985	Honjo et al.			
	4,667,401 ✓	05/01/1987	Clements et al.			
	4,693,770 ✓	09/01/1987	Hatada			
	4,756,756 ✓	07/12/1988	Cassat			
<i>a</i>	4,784,972 ✓	11/01/1988	Hatada			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
<i>Ch</i>	0 154 443	09/11/1985	EP			Full Eng
<i>Ce</i>	2 032 127	04/30/1980	UK			Full Eng
<i>al</i>	2 064 233	06/01/1981	UK			Full Eng
<i>a</i>	2 160 693	12/01/1985	UK			Full Eng
<i>ce</i>	2 182 209	04/27/1973	FR			Conc Stmt
<i>ce</i>	2 525 209	10/21/1983	FR			Conc Stmt
<i>ce</i>	51-102466	09/09/1976	JP			Conc Stmt
<i>al</i>	53-092465	08/01/1978	JP			
<i>ce</i>	58-009124	01/19/1983	JP			Eng Abst
<i>ce</i>	58-148434	09/01/1983	JP			

Examiner

Date Considered

12/06/03

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

11/28/2001

1059 U.S. Pat. 99866/00

11/26/01

Form PTO-1449 (Rev. 8-83)		U.S. Department of Commerce Patent and Trademark Office		Atty Docket 0756-2401		Serial No. N/A	
INFORMATION DISCLOSURE STATEMENT				Applicants: Akira MASE			
				Filing Date: November 29, 2001		Group Art Unit: 1732	
FOREIGN PATENT DOCUMENTS							
Examiner. Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No	
a	60-092648	05/01/1985	JP				
c	60-107845	06/13/1985	JP			Eng Abst	
a	60-108822	06/14/1985	JP			Eng Abst	
a	60-180151	09/01/1985	JP				
c	61-256657	11/14/1986	JP			Eng Abst	
OTHER DOCUMENT (Including Author, Title, Date, Pertinent Pages, Etc.)							
Examiner Initial							
a	IBM Technical Disclosure Bulletin, February 1966, Vol. 8, No. 9						
c	Mitchell et al., "Processing Techniques for Fabricating Thick Film Copper/Dielectric Multilayer Structures", pp. 1-10, May 14-16, 1979, IEEE 29th Electronic Components Conference ✓						
Examiner	Hoan Nguyen			Date Considered	12/06/03 5/23/03		
<p>*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							